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PATENT
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Makoto IIDA et al.

Serial No: Not assigned

Filed: December 12, 2001

For: SILICON WAFER, SILICON EPITAXIAL
WAFER AND ANNEALED WAFER, AND
METHOD FOR PRODUCING THE SAME

Art Unit: Not assigned

Examiner: Not assigned

ASSOCIATE POWER OF ATTORNEY
(37 C.F.R. § 1.34)

Box PCT
Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

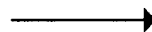
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Please associate this case with this firm's customer number:

☒ Customer Number

000026021

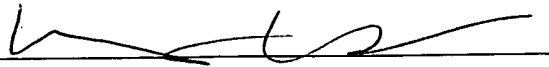


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PATENT TRADEMARK OFFICE

Respectfully submitted,

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